INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

October 12, 2026

IGI Report Number	LG843613530
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OVAL POLYGON STEP CUT
Measurements	9.92 X 4.42 X 2.96 MM

GRADING RESULTS

Carat Weight	1.04 CARAT
Color Grade	F
Clarity Grade	VS 2

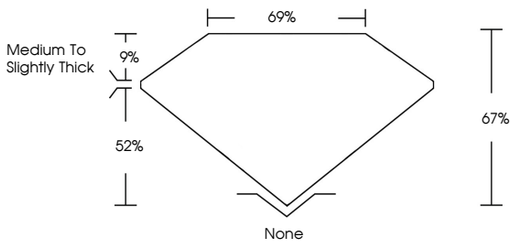
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	VERY GOOD
Fluorescence	NONE
Inscription(s)	LG843613530

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG843613530
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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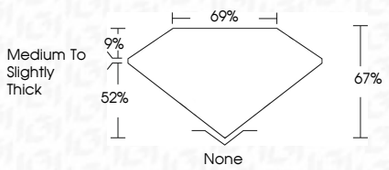
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IGI

October 12, 2026
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OVAL POLYGON STEP CUT
9.92 X 4.42 X 2.96 MM
Carat Weight 1.04 CARAT
Color Grade F
Clarity Grade VS 2
Depth 67%
Table 69%
Girdle Medium To Slightly Thick
Culet None
Polish EXCELLENT
Symmetry VERY GOOD
Fluorescence NONE
Inscription(s) LG843613530
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa